

Docket No.: M4065.0151/P151-B (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AMENDMENT UNDER 37 CFR § 1.116

In re Patent Application of: Vishnu K. Agarwal, et al.

Application No.: 09/930,958

Filed: August 17, 2001

Group Art Unit: 2814

Examiner: Theresa T. Doan

For: MULTILAYER ELECTRODE FOR A FERROELECTRIC CAPACITOR

DO NOT ENTER

MAIL STOP: AF

Commissioner for Patents

P.O. Box 1450

Washington, DC 22313-1450

Dear Sir:

Responsive to the Office Action dated February 27, 2003, please amend the above-captioned application as follows:

IN THE CLAIMS:

Please cancel claim 60

Please rewrite claim 125 as follows:

125. (amended) A memory cell, comprising:

a substrate;

a transistor including a gate on said substrate and a source/drain region in said substrate disposed adjacent to said gate;

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